



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of: **FUKASAWA, Shinji**

Group Art Unit: **2814**

Serial No.: **09/855,590**

Examiner: **T. N. QUACH**

Filed: **May 15, 2001**

P.T.O. Confirmation No.: **1417**

For: **SEMICONDUCTOR DEVICE HAVING A MULTIPLE LAYER WIRING
STRUCTURE, WIRING METHOD, WIRING DEVICE, AND RECORDING MEDIUM**

AMENDMENT UNDER 37 CFR §1.111

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

November 13, 2003

Sir:

In response to the Office Action dated **July 21, 2003**, extended to **November 21, 2003** by
a **one (1)** month Petition for Extension of Time, please amend the above-identified application
as follows:

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